



2877
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
JAMES BROCK STIRTON

Serial No.: 09/824,156

Filed: April 2, 2001

For: METHOD OF MEASURING
IMPLANT PROFILES USING
SCATTEROMETRIC TECHNIQUES

Group Art Unit: 2877

Examiner: Juan D. Valentin

Atty. Dkt. No.: 2000.071000/TT4354

Customer No.: 23720

RESPONSE TO OFFICE ACTION DATED JUNE 11, 2003

Commissioner for Patents
P.O. Box 1450
Washington, DC 20231-1450

Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
September 5, 2003 Date	<i>May Paul</i> Signature

This paper is submitted in response to the Office Action dated June 11, 2003 for which the three-month date for response is September 11, 2003.

No fee is believed to be due in connection with the present paper. However, should any fees be required, the Assistant Commissioner is authorized to deduct any fees required under 37 C.F.R. §§ 1.16 to 1.21 from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT4354. In the event the monies in that account are insufficient, the Assistant Commissioner is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.071000.

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